

Attorney's Docket No.: 977-227002 / US3559D1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hisashi Ohtani Art Unit : 2822
Serial No. : 09/621,943 Examiner : J.L. Brophy
Filed : July 24, 2000
Title : METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE

Commissioner for Patents
Washington, D.C. 20231

RESPONSE

In response to the action mailed September 27, 2001, please
amend the application as follows:

In the specification:

Page 1, the title;

METHOD OF MANUFACTURING AN EL DISPLAY DEVICE

In the claims:

Please amend claim 1 as follows:

B' -- 1. (Amended) A method of manufacturing an EL display device,
said method comprising the steps of:

forming an amorphous semiconductor film comprising
 $\text{Si}_x\text{Ge}_{1-x}$ ($0 < x < 1$) on an insulating surface;

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this
correspondence is being deposited with the
United States Postal Service as first class mail
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December 27, 2001
Date of Deposit

Signature

Richard Donovan
Typed or Printed Name of Person Signing
Certificate